

AMENDMENT UNDER 37 C.F.R. § 1.116 EXPEDITED PROCEDURE GROUP 2828 PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q63516

Eun-kyung LEE, et al.

Appln. No.: 09/835,319

Confirmation No.: 5337

Group Art Unit: 2828

Examiner: RODRIGUEZ, ARMANDO

Filed: April 17, 2001

MULTI-WAVELENGTH SURFACE EMITTING LASER AND METHOD

MANUFACTURING THE SAME

AMENDMENT UNDER 37 C.F.R. § 1.116

ATTN: BOX AF

Commissioner for Patents Washington, D.C. 20231

Sir:

For:

In response to the Office Action dated December 31, 2003, please amend the aboveidentified application as follows:

RECEIVED

APR -3 2003
TECHNOLOGY CENTER 2800